

ABSTRACT

A transfer machine 80 has an arm 810; a holding part 830 that is provided on the arm 810 and that is configured to hold a substrate W; a turning part 100 that turns the arm 810 about a turning axis A; and a control part 50 that adjusts a position in an in-plane direction of the substrate W by turning the arm 810 by the turning part 100 based on the position in the in-plane direction of the substrate W, which is held by the holding part 830, measured by measurement part 110.

Figure 5